Blakely, Sokoloff, Taylor & Zafman LLP (310) 207-3800
Title: Method For Producing By Vapour-Phase Epitaxy a Gallium

Nitride Film With Low Defect Density 1st Named Inventor: Bernard Beaumont

Express Mail No.: EV372843715US Sheet: 1 of 7 Docket No.: 15675P568



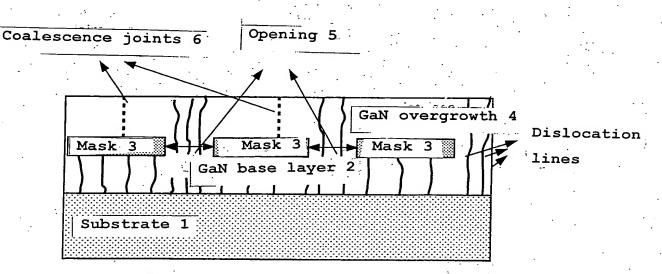
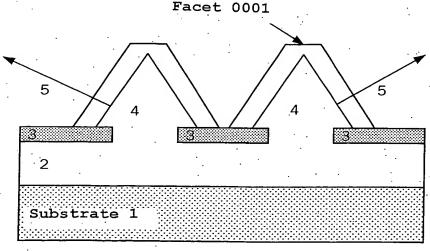


FIG-1 5 2 Substrate 1

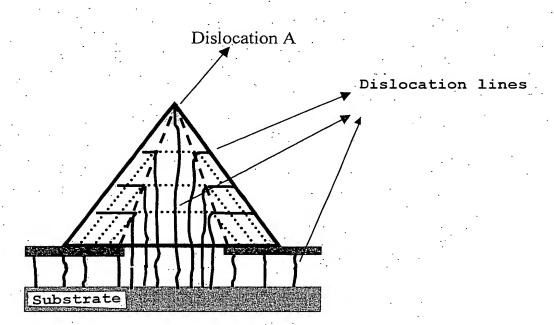
FIG\_2



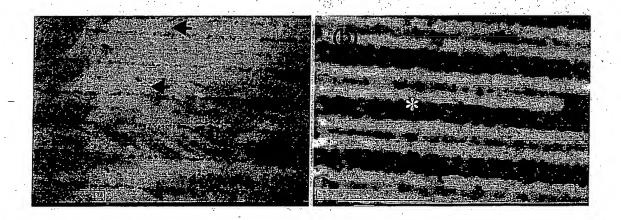
<u>FIG. 3</u>

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FIG\_4



F1G\_5

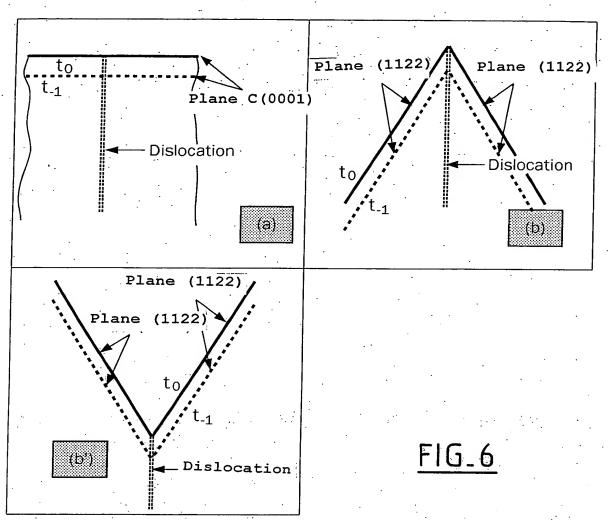
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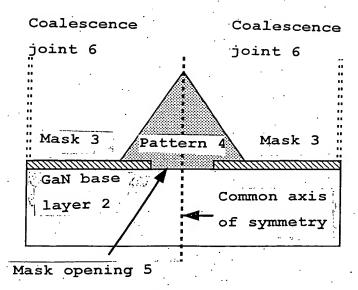
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 $FIG_7$ 

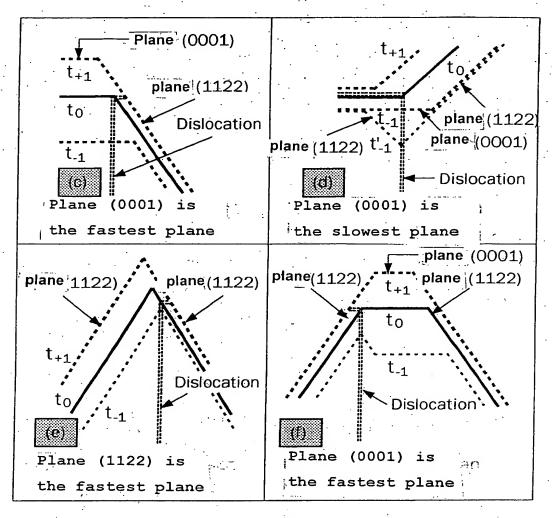
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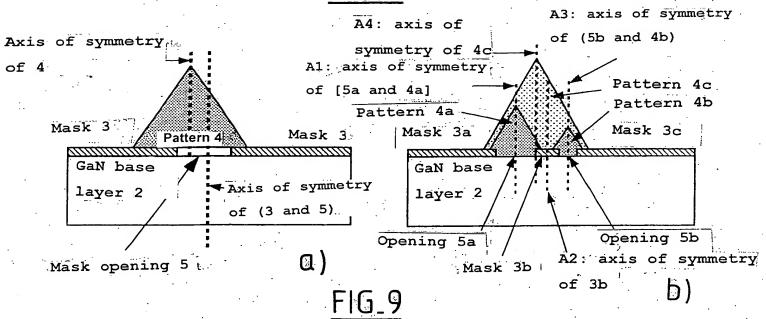
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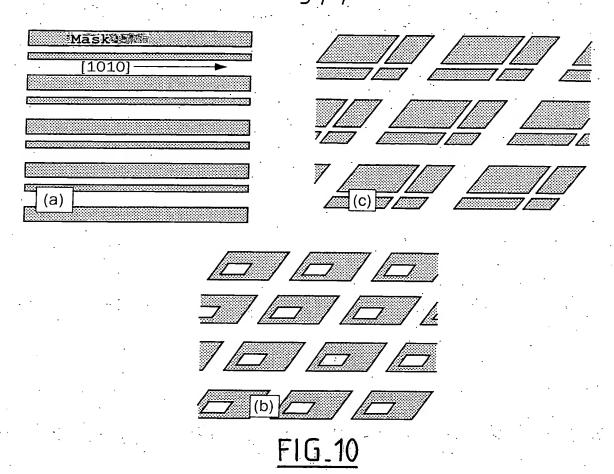
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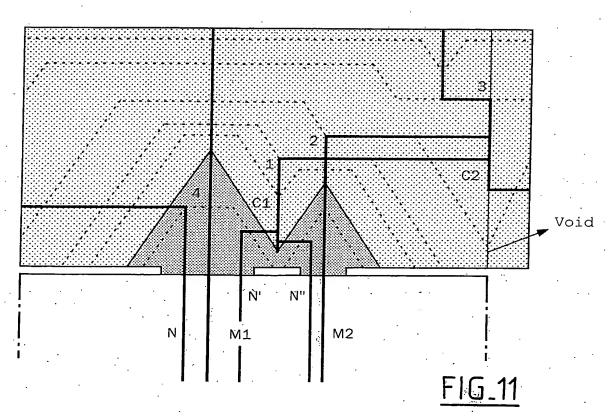
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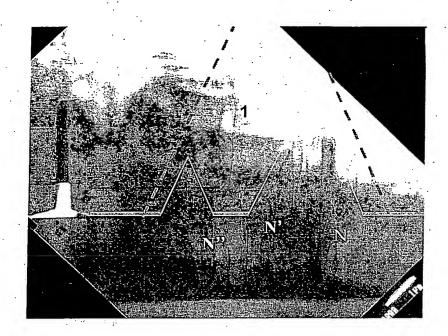
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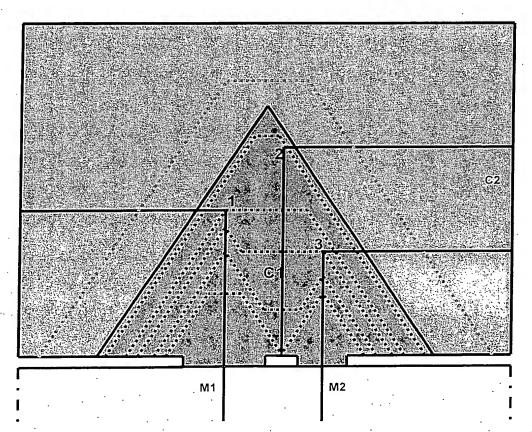
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6 1 7



FIG\_12



FIG\_13

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